

Notice of References Cited	Application/Control No. 10/772,736		Applicant(s)/Patent Under Reexamination JOU ET AL.	
	Examiner David S. Blum		Art Unit 2813	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,828,134 A	10-1998	Lur et al.	257/774
*	C	US-6,025,265 A	02-2000	Miller et al.	438/634
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*	E	US-6,534,866 B1	03-2003	Trivedi et al.	257/752
*	F	US-6,893,957 B2	05-2005	Trivedi et al.	438/632
*	G	US-6,124,204 A	09-2000	Lan et al.	438/687
*	H	US-4,630,357	12-1986	Rogers et al.	438/629
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Stanley wolf SILICON PROCESSING FOR THE VSLI ERA Vol. 4 Lattice Press 2002, page 684
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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